



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of

:

Attorney Docket No. 2006\_0622A

Masahiko SEKIMOTO et al.

:

**Confirmation No. 4763**

Serial No. 10/578,100

:

Group Art Unit 1792

Filed May 3, 2006

:

Examiner Brenda A. Lamb

SUBSTRATE HOLDING APPARATUS,  
SUBSTRATE HOLDING METHOD, AND  
SUBSTRATE PROCESSING APPARATUS

:

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the requirement set forth in the Office Action mailed December 30, 2009,  
Applicants hereby elect invention II, claims 11-14, 18, 20, and 21.

In view of this election, a full examination on the merits of the present application is  
respectfully requested.

Respectfully submitted,

Masahiko SEKIMOTO et al.

By

W. Douglas Hahm  
Registration No. 44,142  
Attorney for Applicants

WDH/kh  
Washington, D.C. 20005-1503  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
January 27, 2010